

IN THE  
UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor(s): Jian-Gang Weng

Confirmation No.: 3288

Application No.: 10/633,208

Examiner: Nhu, David

Filing Date: July 31, 2003

Group Art Unit: 2818

Title: SOLUTION-PROCESSED THIN FILM TRANSISTOR FORMATION METHOD

Mail Stop Amendment  
Commissioner for Patents  
PO Box 1450  
Alexandria, VA 22313-1450

TRANSMITTAL LETTER FOR RESPONSE/AMENDMENT

Sir:

Transmitted herewith is/are the following in the above-identified application:

- (X) Response/Amendment ( ) Petition to extend time to respond  
( ) New fee as calculated below ( ) Supplemental Declaration  
(X) No additional fee  
(X) Other: Drawing Transmittal Letter (fee \$                     )

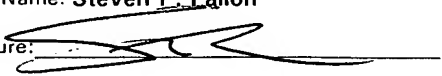
CLAIMS AS AMENDED BY OTHER THAN A SMALL ENTITY						
(1) FOR	(2) CLAIMS REMAINING AFTER AMENDMENT	(3) NUMBER EXTRA	(4) HIGHEST NUMBER PREVIOUSLY PAID FOR	(5) PRESENT EXTRA	(6) RATE	(7) ADDITIONAL FEES
TOTAL CLAIMS	47	MINUS	47	= 0	X \$18	\$ 0
INDEP. CLAIMS	3	MINUS	3	= 0	X \$88	\$ 0
[ ] FIRST PRESENTATION OF A MULTIPLE DEPENDENT CLAIM					+ \$300	\$ 0
EXTENSION FEE	1ST MONTH \$110.00	2ND MONTH \$430.00	3RD MONTH \$980.00	4TH MONTH \$1530.00		\$ 0
OTHER FEES						\$
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT						\$ 0

Charge \$ 0 to Deposit Account 08-2025. At any time during the pendency of this application, please charge any fees required or credit any overpayment to Deposit Account 08-2025 pursuant to 37 CFR 1.25. Additionally please charge any fees to Deposit Account 08-2025 under 37 CFR 1.16 through 1.21 inclusive, and any other sections in Title 37 of the Code of Federal Regulations that may regulate fees. A duplicate copy of this sheet is enclosed.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, Alexandria, VA 22313-1450.

Date of Deposit: Oct. 18, 2004

Typed Name: Steven P. Fallon

Signature: 

Respectfully submitted,

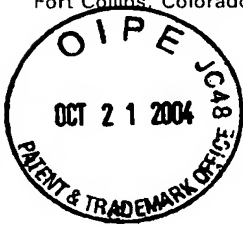
Jian-Gang Weng

By 

Steven P. Fallon

Attorney/Agent for Applicant(s)  
Reg. No. 35,132

Date: Oct. 18, 2004



IN THE  
UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor(s): Jian-Gang Went

Confirmation No.: 3288

Application No.: 10/633,208

Examiner: Nhu, David

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Mail Stop PGPUB Drawings  
Commissioner for Patents  
PO Box 1450  
Alexandria, VA 22313-1450

DRAWING TRANSMITTAL LETTER

Sir:

Enclosed herewith please find:

- (X) 3 sheets of redlined drawing(s) which indicate proposed changes to the drawing(s). Upon approval of these proposed changes, formal drawing(s) will be submitted.
- ( ) \_\_\_\_\_ sheets of corrected formal drawing(s), as required by the Notice of Patent Drawings Objection (PTO-948) which accompanied the Office Action dated \_\_\_\_\_.
- ( ) \_\_\_\_\_ sheets of corrected formal drawing(s), as required by the Notice of Patent Drawings Objection (PTO-948) and approved in the Notice of Allowability dated \_\_\_\_\_.
- ( ) \_\_\_\_\_ sheets of formal drawing(s). Please substitute these formal drawing(s) for the informal drawing(s) originally filed.
- (X) 3 sheets of formal drawings. Upon approval of the proposed changes, the substituted formal drawings are submitted.

Examiner's approval of the entry of these drawings is respectfully requested. No new matter has been added.

Respectfully submitted,

Jian-Gang Went

By

Steven P. Fallon

Attorney/Agent for Applicant(s)  
Reg. No. 35,132

Date: Oct. 18, 2004

Telephone No.: (312) 360-0080

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Date of Deposit: Oct. 18, 2004

Typed Name: Steven P. Fallon

Signature: \_\_\_\_\_



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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Jian-Gang Weng )  
Serial No. 10/633,208 )  
Filed: July 31, 2003 )  
For: SOLUTION-PROCESSED THIN FILM )  
TRANSISTOR FORMATION METHOD) )  
Group Art Unit: 2818 )  
Confirmation No. 3288 )  
Examiner: Nhu, David )

*I hereby certify that this paper is being deposited with the United States Postal Service as FIRST-CLASS mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this date.*

10/18/04

Date  
F-CLASS.WCM  
Appr. February 20, 1998

[Signature]  
Registration No. 3432

Attorney for Applicant

AMENDMENT A

Commissioner for Patents  
Alexandria, VA 22313-1450

Sir:

In response to the office action dated July 20, 2004, please amend the application as follows: